



AF JFW

PATENT  
Customer No. 22,852  
Attorney Docket No. 03180.0278

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	)	
Ryoichi Inanami et al.	)	Group Art Unit: 2881
	)	
Application No.: 09/817,270	)	Examiner: JOHNSTON, Phillip A.
	)	
Filed: March 27, 2001	)	
	)	
For: EXPOSURE PATTERN DATA	)	Confirmation No.: 7690
GENERATION APPARATUS	)	
ASSOCIATED WITH STANDARD	)	
CELL LIBRARY AND CHARGED	)	
BEAM EXPOSURE	)	

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**REQUEST FOR RECONSIDERATION**

In reply to the Office Action mailed June 2, 2005, the period for response extending through September 2, 2005, Applicants respectfully request reconsideration in view of the following remarks.

**Remarks** begin at page 2 of this paper.